

UNITED STATES PATENT AND TRADEMARK OFFICE
CERTIFICATE OF CORRECTION

PATENT NO. : 7,076,756 B2
APPLICATION NO. : 10/701249
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INVENTOR(S) : Junji Ichimiya

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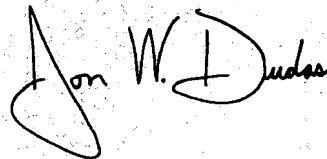
It is certified that error appears in the above-identified patent and that said Letters Patent is hereby corrected as shown below:

Replace the Title section on the cover page of the patent, with the following:

-- (54) LAYOUT DESIGN METHOD FOR SEMICONDUCTOR
INTEGRATED CIRCUIT, AND SEMICONDUCTOR INTEGRATED
CIRCUIT, WITH HIGH INTEGRATION LEVEL OF MULTILEVEL
METALLIZATION--

Signed and Sealed this

Fourteenth Day of August, 2007

A handwritten signature in black ink, appearing to read "Jon W. Dudas". The signature is stylized with a large, looped initial "J" and a distinct "D".

JON W. DUDAS
Director of the United States Patent and Trademark Office